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(MODIFIED)U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

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SERIAL NO.

10/576,105

**LIST OF PRIOR ART CITED BY APPLICANT**  
(Use several sheets if necessary)

APPLICANT(S)

Peter CHOI

FILING DATE

GROUP

**U.S. PATENT DOCUMENTS**

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	2003/058429	03/2003	SCHRIEVER			
	AB	2001/055364	12/2001	KANDAKA et al.			
	AC	5,812,631	09/1998	YAN et al.			
	AD	2002/021782	02/2002	MCDONALD			
	AE	4,219,705	08/1980	HILL			
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

**FOREIGN PATENT DOCUMENTS**

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AL	EP 0 528 542	02/1993	European				
	AM							
	AN							
	AO							
	AP							

**OTHER PRIOR ART** (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR		BORISOV et al.: Relativistic and charge-displacement self-channeling of intense ultrashort laser pulses in plasmas, Physical Review A (Statistical Physics, Plasmas, Fluids, and Related Interdisciplinary topics), 04/1992, Vol. 45, no. 8, pp. 5830-5845
	AS		BOLTON et al.: Propagation of intense, ultrashort laser pulses through preionized plasma slabs, Journal of The Optical Society of America, 02/1997, Vol. 14, no. 2, pp. 437-443
	AT		TSUDA et al.: Physical properties of dense plasma produced by XeCl excimer laser in high-pressure argon gases, Japanese Journal of Applied Physics, Part 1, Vol. 38, no. 6A, 06/1999, pp. 3712-3715

EXAMINER

DATE CONSIDERED

**\*EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

USCOMM-DC 80-3985